

## COMPARISON OF ANATASE AND RUTILE FOR PHOTOCATALYTIC APPLICATION: THE SHORT REVIEW †

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Received June 30, 2021; revised August 8, 2021; accepted September 16, 2021

The dioxide titanium (TiO<sub>2</sub>) is attracting a great attention as semiconductor photocatalyst because of its high photoreactivity, non-toxicity, corrosion resistance, photostability, cheapness. It can be used in wide range of applications: air and water purification, hydrogen (H<sub>2</sub>) generation, CO<sub>2</sub> reduction, in photovoltaic application and others. The efforts of scientists were applied to use solar light for dioxide titanium photocatalysis and to enhance the photocatalytic efficiency. In this article we review the properties difference of anatase and rutile modifications of TiO<sub>2</sub>. The anatase has a higher photoefficiency. The higher photoefficiency of anatase is due to longer lifetime of charge carriers (lifetime of e<sup>-</sup>/h<sup>+</sup> in anatase on 3 order higher than in rutile). But anatase has higher band gap energy (3.2 eV or 388 nm) in comparison with rutile (3.0 eV or 414 nm). Thus, anatase becomes photosensitive in ultraviolet (UV) diapason of light, meanwhile rutile - in violet spectrum of visible light. It is desirable to obtain TiO<sub>2</sub> semiconductor with properties combining best ones from anatase and rutile: higher photoreactivity and smaller band gap. It can be made by using external factors such as electric or magnetic fields, doping and etc.

**Keywords:** photocatalysis, dioxide titanium, anatase, rutile, band gap, photoefficiency, electron-hole generation.

**PACS:** 31.10.+z; 71.20.Nr ; 73.20.-r

### INTRODUCTION

The photocatalytic properties of TiO<sub>2</sub> was firstly reported in 1972 [1]. After that an interest of researchers from whole the world to photocatalysis was attracted. On the fig. 1 it can be seen that the number of the publications from the 70s until 2020 has significantly increased. This can be explained by the following reasons:

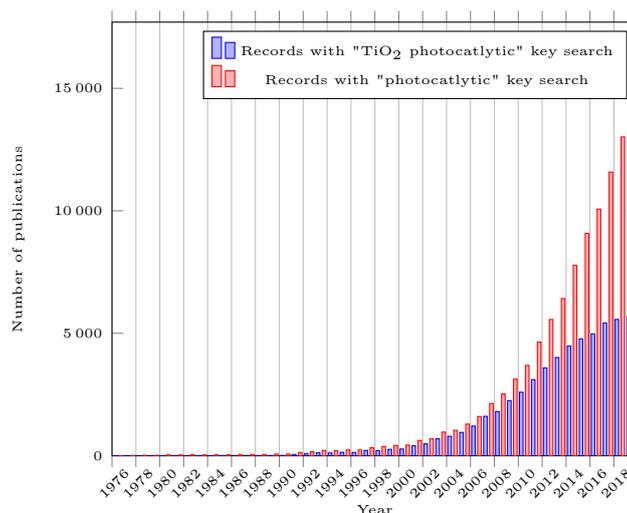
- a wide range of TiO<sub>2</sub> photocatalyst applications:
  - environmental: purification of water and air, CO<sub>2</sub> reduction [2–7];
  - antibacterial and antimicrobial properties [8–11]
  - energy: electricity and hydrogen production [12–16];
  - self-cleaning material and antifogging [17–20];
- high photoreactivity (usually up to  $\zeta$  (photonic efficiency) = 10 %)
- chemically and biologically inert and non-toxic;
- inexpensive;
- corrosion resistant and photostable [21, 22].

On the other hand, the disadvantages are the following [3, 15]:

- low photon utilization efficiency and slow removal rate;
- rapid recombination of photo-generated electron/hole pairs;
- the poor activation of TiO<sub>2</sub> by visible light.

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†**Cite as:** V. Morgunov, S. Lytovchenko, V. Chyshkala, D. Riabchykov, and D. Matviienko, East. Eur. J. Phys. 4, 18 (2021), <https://doi.org/10.26565/2312-4334-2021-4-02>.



**Figure 1:** Number of publications of photocatalysis-related and TiO<sub>2</sub> photocatalysis-related papers for the period 1976 - 2020 years. (Source: Web of Science; date: June 9, 2021; keywords: "photocatalytic" and "TiO<sub>2</sub> photocatalytic".)

To solve first issue the nanosized particles of photocatalyst are used.

To reduce recombination electron/hole pairs (second items) some investigators added sacrificial reagents and carbonate salts [15, 23], doped with metals/non-metals [23, 24], loaded noble metal nanoparticles [25, 26] or applied external electrical field [27, 28].

To use visible light for the enhancement photocatalysis (third issue) some investigations focused on modification of TiO<sub>2</sub> by means of metal loading, metal ion doping, dye sensitization, anion doping and metal ion-implantation [29–36].

The aim of this short review is to summarize what was made in this field and elaborate an direction for further investigations.

### THEORETICAL ASPECTS OF TiO<sub>2</sub> PHOTOCATALYSIS

We briefly consider the TiO<sub>2</sub> lattice structure and the theory of the photocatalysis. Photocatalysis is complicated phenomena and even definition this phenomena has several version [37]. IUPAC Commissions defined photocatalysis as “a catalytic reaction involving light absorption by a catalyst or a substrate” [38]. In a later revised glossary a complementary definition of a photo-assisted catalysis was also proposed: “catalytic reaction involving production of a catalyst by absorption of light” [39]. And in version of 2011 definition of photocatalysis sounds as following "Change in the rate of a chemical reaction or its initiation under the action of ultraviolet, visible, or infrared radiation in the presence of a substance—the photocatalyst—that absorbs light and is involved in the chemical transformation of the reaction partner" [40]. But more practical definition is "Photocatalysis is phenomena that accelerated chemical reaction in the presence of catalyst which absorbed photons".

A detailed knowledge of the surface structure is the crucial first step in obtaining a detailed knowledge of reaction mechanisms on the molecular scale.

The crystal structure of pure titanium lattice is hexagonal close-packed. The lattice constants of Ti have been determined as [41]

$$a_0 = 2.95111 \pm 0.00006 \text{ \AA}$$

$$c_0 = 4.68433 \pm 0.00010 \text{ \AA}$$

$$c/a = 1.5873$$

for a temperature of 25 °C.

Ti hexagonal alpha form changes into a body-centered cubic (lattice) beta form at 882 °C [42].

Titanium dioxide crystallizes in three major different structures:

- rutile (tetragonal, D<sub>4h</sub><sup>14</sup>-P4<sub>2</sub>/mmm, a=b=4.584 Å, c=2.953 Å [43]);
- anatase (tetragonal, D<sub>4h</sub><sup>19</sup>-I4<sub>1</sub>/amd, a=b=3.782 Å, c=9.502 Å [44]);
- brookite (rhombohedral, D<sub>2h</sub><sup>15</sup>-Pbca, a=5.436 Å, b=9.166 Å, c=5.135 Å [44])

Other structures exist as well, for example, cotunnite  $\text{TiO}_2$  has been synthesized at high pressures and is one of the hardest polycrystalline materials known [45].

However, only rutile and anatase play any role in the applications of  $\text{TiO}_2$  and are of any interest here as they have been studied with surface science techniques. Their unit cells are shown in Fig. 2. In both structures, the basic building block consists of a titanium atom surrounded by six oxygen atoms in a more or less distorted octahedral configuration. In each structure, the two bonds between the titanium and the oxygen atoms at the apices of the octahedron are slightly longer. A sizable deviation from a  $90^\circ$  bond angle is observed in anatase. In rutile, neighboring octahedra share one corner along  $\langle 110 \rangle$  – type directions, and are stacked with their long axis alternating by  $90^\circ$ . In anatase the corner-sharing octahedra form  $(001)$  planes. They are connected with their edges with the plane of octahedra below. In all three  $\text{TiO}_2$  structures, the stacking of the octahedra results in threefold coordinated oxygen atoms [46].

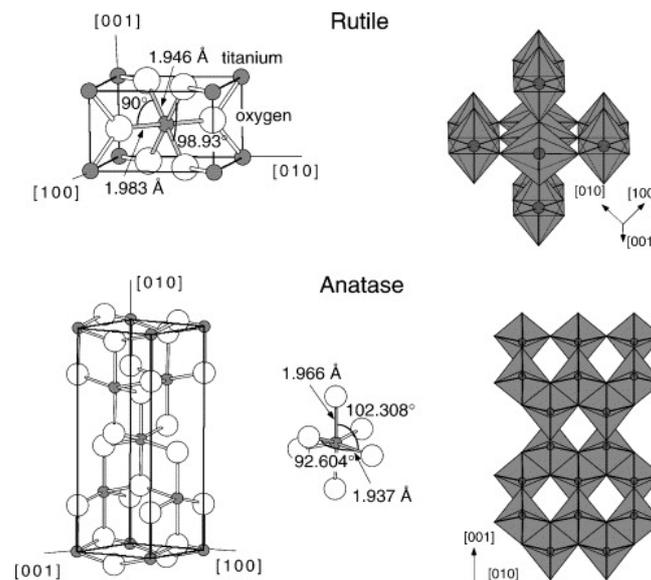


Figure 2: Unit cells of rutile and anatase [46]

$\text{TiO}_2$  is a n-type semiconductor [47]. The parameters of  $\text{TiO}_2$  lattice at different temperatures are given in Table 1 [48]. Comparison of properties of anatase and rutile is given in Table 2 [49].

$\text{TiO}_2$  itself is not a magnetic material, but when it doped by a few percent of Co dioxide titanium becomes a ferromagnetic [60, 61].

### Dark Processes in $\text{TiO}_2$

For semiconductor surface in contact with vacuum surface states are formed. These surfaces alter the electronic structure drastically [47]. As dioxide titanium is covalently bound semiconductor so it has covalent surface states (Shockley states). Surface states on clean surfaces originate from dangling bonds [62]. These surface states introduce additional energy levels in the middle of the bandgap. To achieve electronic equilibrium between the surface and bulk, a positively charged space charged layer is formed just beneath the surface of an n-type semiconductor [21]. Also, usually, the defects on the  $\text{TiO}_2$  surfaces exist in the form of  $\text{O}_{\text{v}}\text{s}$  (s – means surface) by removing surface lattice oxygen atoms in the preparation procedure, leaving behind unpaired electrons (in the Ti 3d orbitals) on the surfaces [63]. These two effects gives the band bending as illustrated on Fig. 3 [46].

Point defects, including  $\text{O}_{\text{v}}\text{s}$ , interstitial titanium ions ( $\text{Ti}^{3+}$ ) and substituted ions, exist in all the crystalline materials of  $\text{TiO}_2$ . Vacancies and interstitial ions are intrinsic defects of crystalline materials, which may significantly affect the catalytic property, mass transport, and electrical conduction of the materials. The point defects introduce new electronic states in the bandgap of  $\text{TiO}_2$ , which are called as defect states. The positions of defect states in the bandgap are affected by the phases and surface structures of  $\text{TiO}_2$ . For example, the defect states of R- $\text{TiO}_2(110)$  are located at  $\approx 0.8 - 1.0$  eV below the CB edge [64]. However, the defect states of A- $\text{TiO}_2(101)$  are located at  $\approx 0.4 - 1.1$  eV below the CB edge [65–69]. Different types of defects in  $\text{TiO}_2$  are shown on Fig. 4 [70].

For realistic cases, when electron-rich  $\text{TiO}_2$  surfaces adsorb different types of adsorbates, charge transfer between surfaces and adsorbates will occur, which may even revert the direction of band bending [69].

**Table 1:** The parameters of TiO<sub>2</sub> lattice at different temperatures

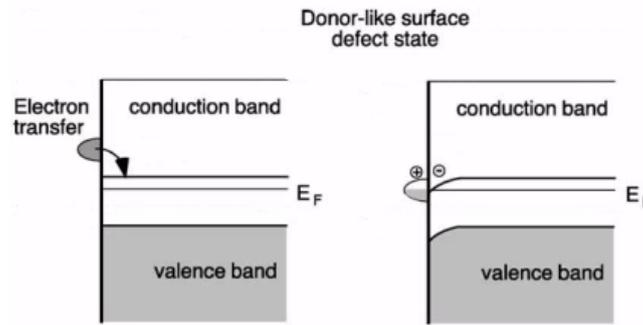
Lattice parameters		Temperature, °C
Dimensions	Lattice constant, Å	
a	3.7845	28
c	9.5143	
a	3.7855	84
c	9.5185	
a	3.7866	161
c	9.5248	
a	3.7875	210
c	9.5294	
a	3.7884	258
c	9.5342	
a	3.7894	306
c	9.5374	
a	3.7907	354
c	9.5432	
a	3.7923	449
c	9.5548	
a	3.7939	497
c	9.5595	
a	3.7948	534
c	9.5669	
a	3.7962	571
c	9.5754	
a	3.7970	608
c	9.5794	
a	3.7989	645
c	9.5872	
a	3.7998	679
c	9.5933	
a	3.8009	712
c	9.5975	

**Table 2:** Properties of anatase and rutile

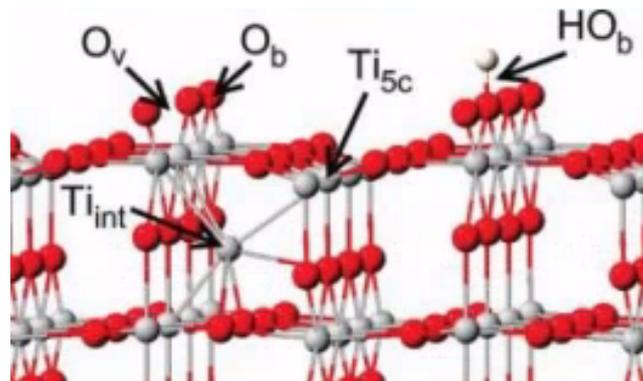
Property	Anatase	Rutile	Reference
Crystal structure	Tetragonal	Tetragonal	[50]
Atoms per unit cell (Z)	4	2	[51]
Space group	$I\bar{4}md$	$P\bar{4}_2nm$	[52]
Type of band gap	$\alpha$ indirect	$m$ direct	[53]
Lattice parameters (nm)	a = 0.3785 c = 0.9514	a = 0.4594 c = 0.29589	[51]
Unit cell volume ( $nm^3$ )	0.1363	0.0624	[51]
Density ( $kg/m^3$ )	3894	4250	[51]
	Calculated band gap		
(eV)	3.23–3.59	3.02–3.24	[54–57]
(nm)	345.4–383.9	382.7–410.1	
	Experimental band gap		
(eV)	~ 3.2	~ 3.0	[56, 58]
(nm)	~ 387	~ 413	
Refractive index	2.54, 2.49	2.79, 2.903	[50]
Solubility in HF	Soluble	Insoluble	[59]
Solubility in $H_2O$	Insoluble	Insoluble	[50]
Hardness (Mohs)	5.5–6	6–6.5	[49]
Bulk modulus (GPa)	183	206	[57]

The accumulation of electrons at the surface determines the surface chemistry of TiO<sub>2</sub>. All processes occurring at the surface of semiconductors are driven to achieve an equilibrium between the Fermi level potential and the chemical potential of the adsorbates, with the position of the Fermi level being equal to the work function of the semiconductor [21].

Deskins et al. [70] suggested that the relative electronegativity of TiO<sub>2</sub> surfaces and adsorbates may perhaps be the key parameter to understand the charge transfer between TiO<sub>2</sub> surfaces and adsorbates. Based on their theoretical works, electron transfer from the TiO<sub>2</sub> surface to adsorbates only occurs when the electronegativity of adsorbates ( $\chi_{adsorbate}$ ) is larger than that of TiO<sub>2</sub> ( $\chi_{TiO_2}$ ) (Figure 5a). Otherwise, no charge transfer occurs (Figure 5b).



**Figure 3:** Schematic diagram of the band-bending effect due to donor-like surface defect states. Surface oxygen vacancies create a defect state and electrons are donated to the system. A charge accumulation layer is created in the near-surface region and the bands in the n-type semiconducting TiO<sub>2</sub> sample bend downwards.



**Figure 4:** Structure of the rutile (110) surface. Red spheres represent O atoms, gray spheres represent Ti atoms, and white spheres represent H atoms. The notable surface sites are the bridging row O atoms (O<sub>b</sub>) and the five-coordinated Ti sites (Ti<sub>5c</sub>). Also shown are defects that lead to surface reduction: O vacancies (O<sub>v</sub>), surface hydroxyls (HO<sub>b</sub>), and interstitial Ti atoms (Ti<sub>int</sub>).

### Illumination of TiO<sub>2</sub>

When exposed to light (sun- or ultraviolet- light), the semiconductor absorbs photons with sufficient energy (more or equal to band gap energy) to inject electrons from the valence band to its conduction band, creating electron/hole pairs [47] as shown on Fig. 6. As magnitude of the band gap for TiO<sub>2</sub> semiconductor is  $\sim 3.2$  eV for anatase modification and  $\sim 3.0$  eV for rutile modification, so there is wavelength threshold of  $\lambda < 388$  nm for anatase and  $\lambda < 414$  nm for rutile to become electronically conductive. It should be noted that in sunlight the percentage of ultraviolet is about 3 % [71].

Photocatalytic reactions can only occur at the TiO<sub>2</sub> surface. After migration to surface of TiO<sub>2</sub> electrons  $e^-$  and holes  $h^+$  can oxidize and reduce absorbed molecules, respectively. Some of electrons and holes are recombined. In fact, time-resolved spectroscopy studies reveal that the most of photogenerated  $e^-/h^+$  pairs ( $\sim 90$  %) recombine rapidly after excitation. This is assumed to be one reason for the relatively low values of photonic efficiency  $\zeta$  (the rate of the formation of the reaction products divided by the incident flow) [21].

Schematically these steps are shown on Fig 7 [72] and in the following table [73]:

**Table 3:** Schematic model illustrating the main steps associated with TiO<sub>2</sub> photocatalysis

No of step	Reaction	Time
1	Charge carrier generation: $TiO_2 \xrightarrow{h\nu} TiO_2(e_{CB}^- + h_{VB}^+)$ and thermalization: $e^{-*} \rightarrow e^- + heat(phonons)$ $h^{+*} \rightarrow h^+ + heat(phonons)$	<100 fs  10 fs
2	Trapping CB electrons ( $e_{cb}^-$ ) at defect $Ti^{4+}$ sites: $Ti_{ds}^{4+} + e_{cb}^- \rightarrow Ti_{ds}^{3+}$ [74]	200 fs
3	Trapping valence band holes ( $h_{vb}^+$ ) at terminal Ti-OH or surface Ti-O-Ti sites: $Ti-O_sH$ or $Ti-O_s-Ti + h_{vb}^+ \rightarrow Ti-O_sH^+$ or $Ti-O_s^+-Ti$ [74]	200 fs
4	Reduction of adsorbed electron acceptor ( $A_{ad}$ ) with $e_{cb}^-$ at reduction sites: $e_{cb}^- + A_{ad} \rightarrow A_{ad}^-$	>10 ns
5	Reduction of $A_{ad}$ with electrons trapped at defect sites ( $Ti_{ds}^{3+}$ ): $Ti_{ds}^{3+} + A_{ad} \rightarrow Ti_{ds}^{4+} + A_{ad}^-$	slow process

6	Oxidation of adsorbed electron donor ( $D_{ad}$ ) by trapped holes at oxidation sites: $Ti - O_s H^{+}$ or $Ti - O_s^{+} - Ti + D_{ad} \rightarrow Ti - O_s H$ or $Ti - O_s - Ti + D_{ad}^{+}$	100 ps-10 ns
7	Recombination of $e_{cb}^{-}$ with trapped holes [75]:  $e_{cb}^{-} + Ti - O_s H^{+}$ or $Ti - O_s^{+} - Ti \rightarrow Ti - O_s H$ or $Ti - O_s - Ti$	<i>rutile</i> 24 ns <i>anatase</i> $\sim$ few ms
8	Recombination of $Ti_{ds}^{3+}$ with trapped holes [75]:  $Ti_{ds}^{3+} + Ti - O_s H^{+}$ or $Ti - O_s^{+} - Ti \rightarrow Ti_{ds}^{4+} + Ti - O_s H$ or $Ti - O_s - Ti$	<i>rutile</i> [48 ns] <i>anatase</i> [ $\sim$ few ns]

### Charge carrier generation and thermalization

Charge carrier generation in anatase and rutile is running in different ways because anatase belongs to indirect band gap semiconductor, rutile - to direct one [76]. The schemes of direct and indirect band gaps are shown on Fig. 8a. Indirect transitions involve either the absorption of both a photon and a phonon or the absorption of a photon and the emission of a phonon. The conditions for indirect transitions, as shown in Fig. 8a, can be summarized in the following way [76]. For the conservation of momentum,

$$k_{ph} = k_f - k_i$$

where  $k_{ph}$  is the wave vector for the phonon, and  $k_f$  and  $k_i$  are the wave vectors for the final and initial states of the transition, respectively.

For direct transitions  $k_{ph} = 0$  and for indirect transitions  $k_{ph} \neq 0$ .

After illumination of  $TiO_2$  by UV photons with energy more or equal to band gap width free electrons and holes are generated (fig. 6). It should be noted that the penetration depth  $\delta_p$  of ultraviolet light in  $TiO_2$  is approximately equal to 160 nm [77]. Therefore electron-hole pairs are generated in the outer surface region of the  $TiO_2$ . Due to the near surface electric field the recombination of  $e^{-}/h^{+}$  is retarded [21].

Continuous illumination will result in the annihilation of this electric field, that is, a band flattening [78]. Yates et al. [21, 79] explained the appearance of this band flattening by a band shifting at the surface, because the free electrons move to the bulk, while free holes accumulate at the surface where the negative charge is neutralized. However, band flattening can also be explained by a band shifting in the bulk region, as the number of electrons increases in the bulk upon illumination.

According to electron paramagnetic resonance (EPR) spectroscopy process of pair generation occurs in femtoseconds [80] ( $1 \text{ fs} = 10^{-15} \text{ s}$ ) up to 100 fs. But it is obviously that  $e^{-}/h^{+}$  pair generation time for indirect and direct  $TiO_2$  modifications (anatase and rutile, respectively) is differ. There is no data in literature concerning this difference in time of the charge carrier generation.

In an ideal photocatalyst, all photon energy invested in charge carrier generation would be available for redox reactions, namely, hot electrons (or deep holes) produced by shorter wavelength light have more reductive (or oxidative) capacity than those at the band edges of a photocatalyst [69]. However, charge carrier thermalization occurs rapidly.

After  $e^{-}/h^{+}$  generation the energetic electrons continue to travel in the solid, losing its energy and producing shallower core holes. This cascade process, often called "thermalization", is repeated until the hole is created at the top of valence band and fully thermalized electrons settling in the bottom of the conduction band [81].

In [82] authors found that time of thermalization in  $TiO_2$  (110) is equal to 10 fs.

These studies clearly demonstrate that charge carrier thermalization occurs prior to recombination or transfer.

### Electron and hole trapping

Once produced, the charge carriers become trapped, either in shallow traps (ST) or in deep traps (DT) [80]. The photogenerated charge carriers can be trapped in either in bulk or on the surface. In generally, surface trapping at either the subsurface or the surface region is preferred in semiconductor nanoparticles [83, 84].

Because of the upward band bending in n-type  $TiO_2$ , the photogenerated electrons are forced to move from its surface into the bulk, where they can be delocalized over different Ti sites. Both theoretical and experimental studies are predicting bulk (subsurface) trapping rather than surface trapping of these electrons [85–87]. However, alternative studies also exist demonstrating that  $Ti^{4+}OH$  groups located at the  $TiO_2$  surface can act as trapping centers for the electrons, resulting in the formation of  $Ti^{3+}OH$  species. Such species can attract holes, thus behaving as recombination centers [88–90].

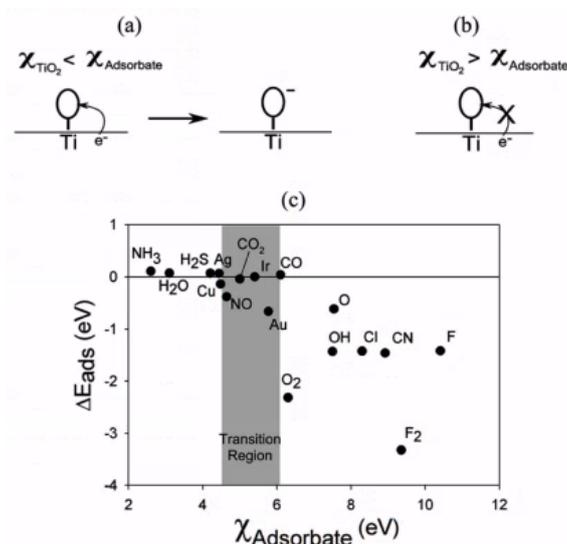


Figure 5: The effect of electronegativity on the adsorption energy of adsorbates on  $TiO_2$ .

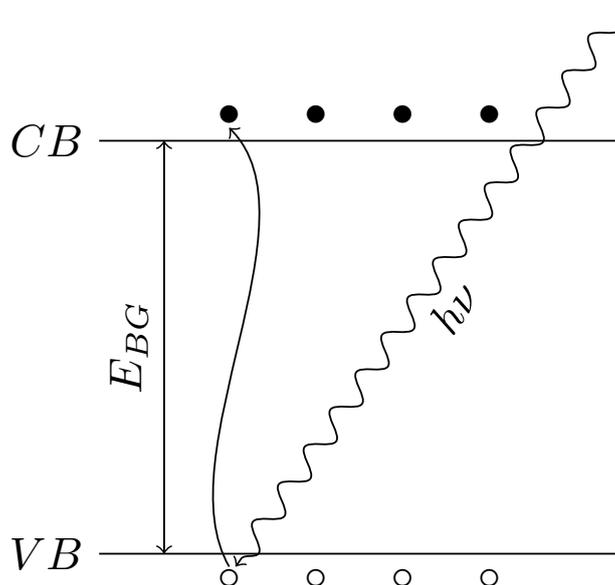


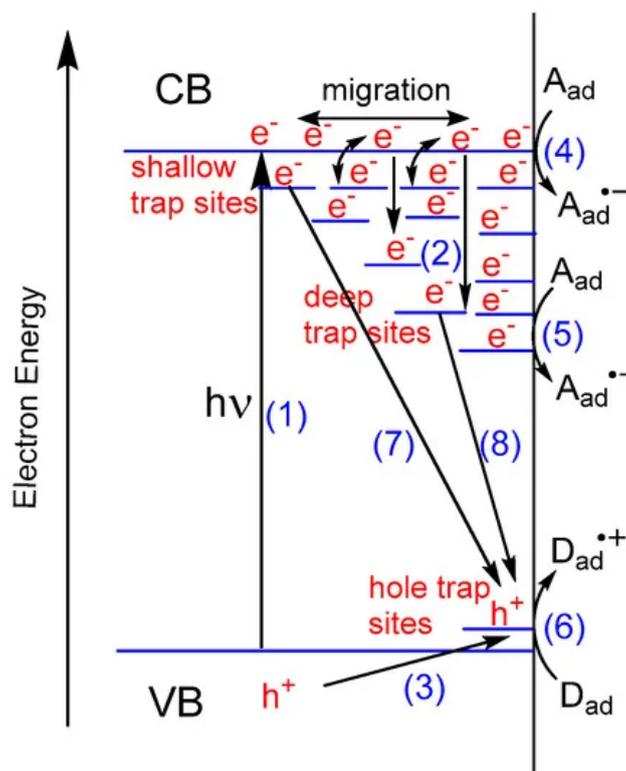
Figure 6: Scheme of electron/hole formation in the semiconductors.  $CB$  - conduction band,  $VB$  - valence band,  $E_{BG}$  - energy band gap,  $\circ$  - holes,  $\bullet$  - electrons,  $h\nu$  - photon.

Upon 355 nm excitation, photogenerated electrons and holes are trapped very rapidly within 100 fs. However, the excess energy of free electrons in the  $TiO_2$  CB slows the trapping time to  $\approx 200$  fs upon 266 nm irradiation [91].

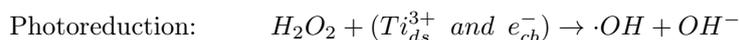
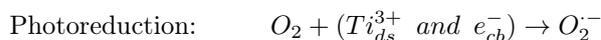
#### Reduction of electron acceptors $A_{ad}$ with electrons and oxidation of adsorbed electron donor $D_{ad}$ by holes

Following their formation by light excitation, electrons and holes can easily be transferred to electron and hole acceptors, respectively. The quantum efficiency of these reactions depends on the charge-transfer rate at the interface, on the recombination rate within the particle, and on the transit time of the photogenerated charge carriers to the surface [21].

Photocatalytic reactions occur on the surface of semiconductor. Photocatalytic reactions can be reduction and oxidation ones. These reactions are form reactive oxygen species (ROS), such as superoxide anion radicals ( $O_2^-$ ), hydroperoxy radicals ( $\cdot OOH$ ), hydrogen peroxide ( $H_2O_2$ ), and hydroxyl radicals ( $\cdot OH$ ), under both aqueous and aerated conditions [21, 92]. These ROS play a crucial role in the photocatalysis on  $TiO_2$  for water purification, air cleaning, self-cleaning, self-sterilization, etc. The reduction reactions on photo-irradiated  $TiO_2$  under acidic conditions can be depicted as follows [21, 73, 92, 93]:



**Figure 7:** Schematic model illustrating the main steps associated with  $\text{TiO}_2$  photocatalysis



In oxidation reactions hydroxyl radicals  $\text{OH}$  are formed via direct hole oxidation of adsorbed  $\text{H}_2\text{O}$  [94]:



There are two types of  $\cdot\text{OH}$  radicals: free mobile ( $\text{OH}_f$ ) and surface bound ( $\text{OH}_s$ ) hydroxyl radicals, which exhibit different reactivities depending on the properties of target pollutants. The  $\text{OH}_f$  generation and the subsequent diffusion from the surface are critical in achieving the mineralization of non-adsorbing substrates by extending the reaction zone from the surface to the solution bulk [95].

For environmental application main role plays free hydroxyl radical  $\text{OH}_f$ . As mentioned in [95] these radicals are producing mainly by anatase modification of titanium dioxide.

### The electron-hole recombination

The electron-hole recombination process is undesirable one because it reduce efficiency of photochemical reactions occurring on the surface of  $\text{TiO}_2$ . As it was above mentioned about 90 % of charge carriers recombine decreasing efficiency of the photocatalytic reactions.

The electron-hole recombination is found to be quite rapid cases, with a majority of recombination complete within 50 ps[96]. In [97] revealed significantly higher yields and longer lifetimes of charge carriers in the anatase powder. Yamada et al [75] stated that electrons lifetime in rutile is equal to 24 ns, in anatase - microseconds; lifetime of holes in rutile is equal to 48 ns, in anatase - nanoseconds. The longer charge carriers lifetime in anatase is one of the main reason why anatase has more photoactivity property.

There are three basic recombination mechanisms that are responsible for carrier annihilation in a semiconductor [98]:

1. band-to-band recombination, which occurs when an electron moves from the conduction band (CB) to the empty valence band (VB) containing a hole (the rate of band-to-band recombination depends on

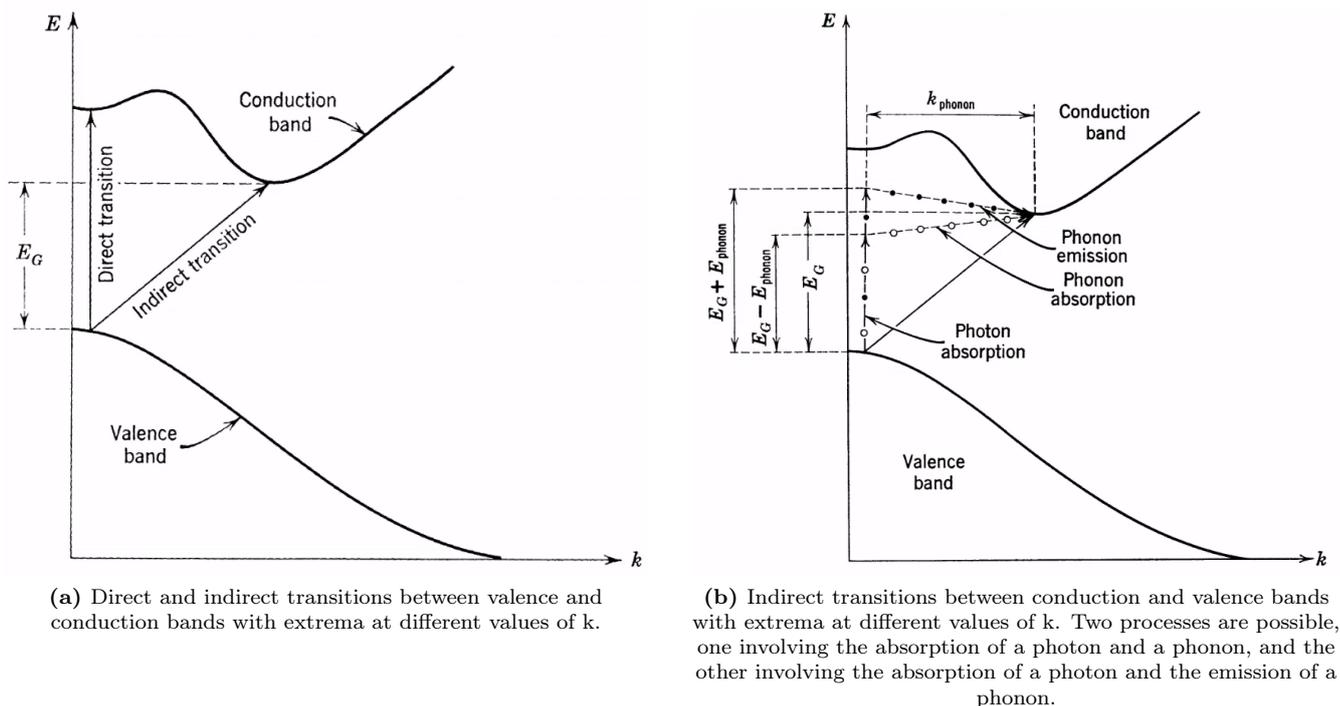


Figure 8: Direct and indirect transitions between valence and conduction bands [76].

the product of the concentrations of available electrons and holes and is second order in charge carrier concentration];

2. trap-assisted recombination (Shockley-Read-Hall Model, SRH model), which occurs when an electron in the CB recombines indirectly with a hole in the VB at a “trap” state;
3. Auger recombination, which occurs when an electron-hole pair recombine in a band-to-band transition giving off the generated energy to another electron or hole.

The electron-hole recombination process reaction successfully compete with the hole-transfer [99].

As it was mentioned earlier time of electron-pair recombination in rutile shorter than in anatase. This is one of the main reason why anatase is more photoactive. This is because of that anatase has indirect band gap and to recombine the

OH generation

## CONCLUSION

In the article the difference between anatase and rutile was considered as from photocatalytic point of view as well as from structure point of view. The main differences are

- Cell volume of rutile smaller than anatase one by factor  $\approx 2$ .
- Rutile is more stable modification of dioxide titanium in comparison with anatase.
- Width of band gap in anatase is equal to 3.2 eV (388 nm - ultraviolet light), meanwhile, rutile has width of band gap equal to 3.0 eV that corresponds to 414 nm that is in visible diapason of light.
- Anatase has indirect transitions between conduction and valence bands, rutile - direct.
- Recombination of electron/hole pairs is quicker in rutile than in anatase because recombination in anatase slower because it has indirect transition in band gap.
- Free radical  $OH_f$  can be generated by anatase only.

Thus, anatase has more photocatalytic activity in comparison with rutile because of more longer lifetime of charge carriers. But the width of rutile band gap is narrower so rutile has photocatalytic properties in visible diapason of light - the aim of last decade of investigations. It is desire to increase time life of electrons and holes in rutile. It can be done by external forces, for example electric or magnetic fields.

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## ПОРІВНЯННЯ ВЛАСТИВОСТЕЙ АНАТАЗА І РУТИЛА ДЛЯ ФОТОКАТАЛІТИЧНОГО ВИКОРИСТАННЯ: КОРОТКИЙ ОГЛЯД

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Діоксид титану (TiO<sub>2</sub>) привертає велику увагу як напівпровідниковий фотокаталізатор через свою високу фотореактивність, нетоксичність, корозійну стійкість, фотостійкість, дешевизну. Він може бути використаний у широкому спектрі застосувань: очищення повітря та води, генерування водню (H<sub>2</sub>), зменшення вмісту CO<sub>2</sub>, у фотоелектричних пристроях тощо. Зусилля вчених були направлені на пошук способів, що використовують сонячне світло для фотокаталізу за допомогою діоксиду титану та підвищення фотокаталітичної ефективності. У цій статті ми розглядаємо різницю властивостей модифікацій анатазу та рутилу TiO<sub>2</sub>. Анатаз має більш високу фотоефективність. Більш висока фотоефективність анатазу обумовлена більш тривалим терміном життя носіїв заряду (час життя e<sup>-</sup>/h<sup>+</sup> в анатазі на 3 порядки вище, ніж у рутилу). Але анатаз має більшу ширину забороненої зони (3,2 eV або 388 нм) у порівнянні з рутилом (3,0 eV або 414 нм). Таким чином, анатаз стає світлочутливим в ультрафіолетовому (УФ) діапазоні світла, тим часом рутил - у фіолетовому спектрі видимого світла. Бажано отримати напівпровідник TiO<sub>2</sub> з властивостями, що поєднують найкращі як для анатазу так і для рутилу: більша фотореактивність та менша забороненої зони. Це можна зробити за допомогою зовнішніх факторів, таких як електричне або магнітне поле, легування тощо.

**Ключові слова:** фотокаталіз, діоксид титану, анатаз, рутил, ширина забороненої зони, фотоефективність, генерація електронних дірок.